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**SPECIAL UNION FOR THE INTERNATIONAL PATENT CLASSIFICATION
(IPC UNION)**

COMMITTEE OF EXPERTS

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IPC AND TECHNOLOGY CONCORDANCE TABLE

Document prepared by the Secretariat

1. Patent statistics provide valuable information about innovative activity. In order to establish such statistics, a concordance between predefined fields of technology and the IPC has been used for several years by WIPO and other Intellectual Property Offices. Lately, these fields of technology have been reviewed and the concordance has been revised.

1. The Annex to this document contains a paper commissioned by WIPO that explains the current concordance table for 35 different fields of technology and the modifications in comparison to the previous concordance, as well as gives an explanation of the general approach. The new concordance has already been used for WIPO's 2008 World Patent Report and can also be found at: <http://www.wipo.int/ipstats/en/statistics/patents>.

2. *The Committee of Experts is invited to take note of the contents of the Annex to this document.*

[Annex follows]